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Advanced Robotics and Mechatronics Devices

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Message from the Guest Editor

Dear Colleagues,

Mechatronics and robotics have been widely used in many arenas, such as manufacturing, medical, and space. Currently, the use of mechatronics and robotics are limited with respect to performance capabilities. Improving the performance of manufacturing robotic and mechatronic systems is, and still will be, the main topic for researchers and engineers.

This Special Issue aims to bring researchers together to present recent advances and technologies in the field of mechatronics, robotics, and MEMS devices. Topics include, but are not limited, to:

Advanced mechatronics;
New MEMS devices design;
Parallel mechanisms based F/T sensors
New control theories for robotics and MEMS devices
Dynamic characteristics improvement for robotic devices

Prof. Dr. Dan Zhang
Guest Editor



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Special Issue



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Message from the Editor-in-Chief

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